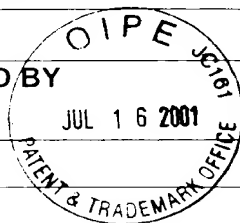


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(Use several sheets if necessary)		Filing Date February 16, 2001	Group Unknown
Examiner Unknown			

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<i>fun</i>	A4	6,024,856	02/15/2000	Haydu, et al.	205	84	10/10/1997
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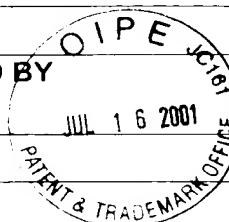
*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
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<i>fun</i>	C2	"Metallization & Interconnect", SEMITool Products Sales, October 27, 1998, 4 pages.
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	Date Considered	<i>2/20/03</i>

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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<i>hm</i>	A30	5,222,310	06/29/1993	Thompson, et al.	34	202	01/11/1991
<i>hm</i>	A31	5,162,260	11/10/1992	Leibovitz, et al.	437	195	01/07/1991
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<i>hm</i>	A33	5,092,975	03/03/1992	Yamamura, et al.	204	198	06/15/1989
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Examiner <i>Greg M. Moch</i>	Date Considered <i>2/20/01</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.	

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<i>an</i>	A44	4,428,815	01/31/1984	Powell, et al.	204	297	04/28/1983
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							YES	NO
<i>I</i>	B14							
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<i>an</i>	C8	"Electric Contacts Theory and Application", Holm, R., Springer-Verlag New York Inc, 1967, 27 pages.

Examiner <i>Sybil Walker</i>	Date Considered <i>2/24/05</i>
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<i>SW</i>	A54	3,770,598	11/06/1973	Creutz	204	52R	01/21/1972
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<i>I</i>	B17							
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<i>I</i>	C09	
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<i>1</i>	B20							
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Examiner

Argelia Lopez

Date Considered

2/7/03

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